

John J. Petillo (Senior Member, IEEE) received the B.S. degree in electrical engineering from Northeastern University, Boston, MA, USA, in 1980, and the Ph.D. degree in applied plasma physics from the Massachusetts Institute of Technology, Cambridge, MA, USA, in 1986. His dissertation was on equilibrium and stability analysis of the modified betatron accelerator. He has been with Leidos Inc., Reston, VA, USA, formerly (Science Applications International Corporation/SAIC), since 1986. Since joining Leidos/SAIC, he has been involved in the research and development of analysis software and analysis and advanced modeling and simulation of RF components, including vacuum electronics, emission physics, accelerator components, microwave devices, ion beam lithography, and ion thrusters. He has been a Lecturer with the U.S. Particle Accelerator School on several occasions on EM-PIC modeling. He is currently the Director of the Center for Electromagnetic Science, Leidos Innovation Center, and the Research and Development Manager and an author of the MICHELLE, MASK, AVGUN, and ARGUS Codes.